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AF/1763/IFW

PATENT

Docket No. 506212000600

CERTIFICATE OF HAND CARRY

I hereby certify that this correspondence is being hand carried to: Commissioner for Patents, Alexandria, VA 22313-1450, on May 11, 2004.

Valencia Venzant
Valencia Venzant



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Michihiko YANAGISAWA

Serial No.: 10/098,588

Filing Date: March 18, 2002

For: WAFER TABLE FOR LOCAL DRY
ETCHING APPARATUS

Examiner: Ram N. Kackar

Group Art Unit: 1763

RESPONSE UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Action mailed January 14, 2004, please reconsider this application in light of the following remarks:

REMARKS

The disclosure of the specification has been objected to because of the expression "half value width" in paragraphs 4 and 5 of the specification. In response to applicant's explanation on the meaning of the half value width in the amendment filed December 16, 2003, the Examiner admits that this expression is well established in the art. However, in this Action the Examiner alleges that the half value width is arbitrary because the etch pit profile shown in FIG. 2 of the